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Applicant: Ilyun-Jae Kim, et al.)
Serial No.: 10/663,081) Group Art Unit:
Filed: September 16, 2003) 1756
For: MASK FOR POLYCRYSTALLIZATION AND)
METHOD OF MANUFACTURING THIN FILM)
TRANSISTOR USING)
POLYCRYSTALLIZATION MASK)

VIA FACSIMILE TO 1-703-872-9306
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Office action of November 29, 2004, Applicants request reconsideration in view of the following amendments and remarks for entry in the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.

I hereby certify that this correspondence, consisting of 9 total pages, was facsimile transmitted to the United States Patent Office (Fax No. 1-703-872-9306) on	
April 29, 2005 (Date of Deposit)	
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<i>[Signature]</i> Signature	04/29/05 Date

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